



**INTERNATIONAL
GEMOLOGICAL
INSTITUTE**

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LG816620178
Report verification at igi.org

LABORATORY GROWN DIAMOND REPORT



July 23, 2026

IGI Report Number **LG816620178**Description **LABORATORY GROWN DIAMOND**Shape and Cutting Style **ROUND BRILLIANT**

Measurements 6.54 - 6.61 X 4.01 MM

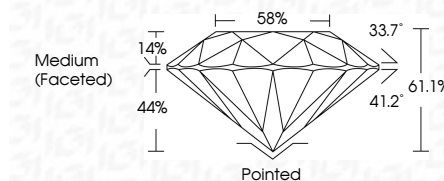
GRADING RESULTS

Carat Weight 1.05 CARAT

Color Grade

Clarity Grade VS 2

Cut Grade **IDEAL**



ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**Symmetry **EXCELLENT**Fluorescence **NONE**Inscription(s) LG816620178

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa



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July 23, 2026
GJ Report No. 19816620178

July 23, 2020
GI Report No LG81
DOING BRILLIANT

5.54 - 6.61 X 4.01 MM

3.54 - 6.61 X 4.01 MM
1.05 CARAT
Carat Weight

Color Grade F

Clarity Grade	VS2
VS2	

Out Grade **IDEAL**

	61.1%	58%
Depth		
Table		

	Girdle	Medium (Faceted)	Coat
1			
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	Pointed	Excellent
Culet		
Polish		

EXCELLENT	symmetry
EXCELLENT	

Fluorescence	NONE
Fluorescence	NONE

Subscription(s)

Comments:
This Laboratory Grown Diamond was

Created by Chemical Vapor Deposition (CVD) growth process

Type IIa